PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Miho WATANABE et al.

Application No.: New U.S. Patent Application

Filed: January 29, 2004 Docket No.: 118484

For: RESISTANCE ELEMENT, METHOD OF MANUFACTURING THE SAME, AND THERMISTOR

<u>INFORMATION DISCLOSURE STATEMENT</u>

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. Relevance of references 1 & 3 is discussed in the present specification.
- 3. An English-language Abstract of the non-English language reference is attached hereto. (Ref. 1)
- 4. A computer-generated English translation of the following Japanese Patent Publication has been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy. See Reference 1.

S. Reference 2 corresponds to JP 2002-503204A cited in the specification.

Respectfully submitted,

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JAO:JSA/amo

Date: January 29, 2004

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400 DEPOSIT ACCOUNT USE
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Sheet 1 of 1

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INFORMATION DISCLOSURE STATEMENT											
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	1	JP A 2002-110402 w/ abst & trans	04/1	12/2002	Japan						
	2	WO 97/32571	09/1	12/1997	WIPO						
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)											
	3	Lyubchenko, Y.L. et al. "Atomic force	DNA and bacteriophage	e in air, water ar	nd prop	panol: the ro	ole of				
	Adhesion forces." Nucleic Acids Research, 1993, Vol. 21, No. 5 pp. 117-1123										
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Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.											

Date: January 29, 2004